



Attorney Docket No. 0756-1921

2813  
JPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hisashi OHTANI et al.

Serial No. 09/226,216

Filed: January 7, 1999

For: SEMICONDUCTOR DEVICE AND  
METHOD OF MANUFACTURING  
THE SAME

) Group Art Unit: 2813

) Examiner: L. Schillinger

) CERTIFICATE OF MAILING

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**AMENDMENT AND RESPONSE TO ELECTION REQUIREMENT**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 9 of this paper.